Dynavac

THIN FILM DEPOSITION

The Odyssey 450 is the perfect solution for those needing small-scale production with the high quality results of a large, sophisticated system. Whether it's pilot production or R&D, the Odyssey's versatile design supports many types of deposition methods to produce highly efficient, uniform thin films for even the most complex applications.



The Odyssey 450 delivers the results you expect with the trusted support of a market leader.

ODYSSEY 450 **Deposition Systems**

The Odyssey's base system comes equipped with a 450mm vacuum chamber, pumping system, and Dynavac's LabVIEW-based supervisory control system, all housed in a portable, modular cabinet. Choose just the right process equipment from a comprehensive package of deposition sources, tooling configurations, and thickness control methods. The Odyssey's flexible design platform also makes re-tooling possible to support future process applications, maximizing your investment for years to come.

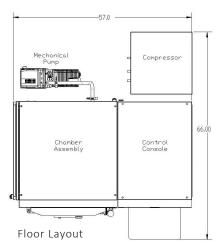
The Odyssey 450 is part of Dynavac's complete platform of resources to support you from initial design through everyday operation. Process development support is available through our team of process engineers and our dynamic customer support team ensures your investment is protected through the life of your equipment.

SPECIFICATIONS

Vacuum Chamber	 450mm w x 450mm d x 600mm h stainless steel chamber Full opening front door with 4" viewport
Pumping System	 Turbomolecular pump or cryopump for high vacuum pumping Rotary vane pump for chamber roughing
Controls & Instrumentation	PLC with LabVIEW interfacePower distribution systemVacuum gauge package
Startup & Training	 Pre-shipment startup & training
Available Options	
Vacuum Chamber	Water-coolingAdditional ports
Pumping System	Dry mechanical pump



Rear Internal View



Process Equipment

Substrate Fixturing

Electron beam source

Planetary mechanism

- Resistance evaporation source
- Ion source

Static fixture

- Substrate heat
- Single or multiple sputter cathodes
- RF / DC / Pulsed power supplies
- Glow discharge system
- Process gas control

Controls & Instrumentation

Enhanced control system (data logging, trending, etc.)

Single rotation fixture (multiple configurations)

- Quartz crystal monitor
- Dynavac Spectrum Pro Optical Monitor
- Residual gas analyzer
- Plasma emission monitor

Startup & Training

Onsite installation, startup, & training



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